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PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1765**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuyoshi TAMURA et al.

Group Art Unit: 1765

Application No.: 09/696,955

Examiner: M. A. Anderson

Filed: October 27, 2000

Docket No.: 10770

For: SILICON FOCUS RING AND METHOD FOR PRODUCING THE SAME

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In reply to the June 12, 2002 Final Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

IN THE DRAWINGS:

Please replace Figures 1A, 1B and 2 pursuant to the attached Letter to the Official Draftsperson.

REMARKS

Claims 1-6 are pending. By this Amendment, the drawings are replaced pursuant to the Letter to the Official Draftsperson. No new matter is added by any of these amendments.

Reconsideration based on the following remarks is respectfully requested.

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